

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yasunori Ito, et al.

Serial No.: 10/640,850

Filed: August 13, 2003

For: METHOD OF PRODUCING  
CERAMIC THERMISTOR  
CHIPS

Group Art Unit: 1795

Confirmation No.: 9131

Examiner: H. D. Wilkins III

Attorney Docket: MURTP083D1

**CERTIFICATE OF EFS-WEB  
TRANSMISSION**

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 21, 2008.

Signed: /dn/  
Deborah Neill

**EXPRESS ABANDONMENT OF APPLICATION (37 CFR 1.138)**

Mail Stop Express Abandonment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The applicant hereby expressly abandons this case

Respectfully submitted,  
/kn/

Keiichi Nishimura  
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November 21, 2008  
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